

Application/Control No.	Applicant(s)/Patent under Reexamination NISHIYAMA ET AL.	
10/669,320		
Examiner	Art Unit	
Kenneth A. Parker	2871	

	SEARCHED				
Class	Subclass	Date	Examiner		
349	139	6/21/2005	KP		
	143	6/21/2005			
	129	6/21/2005			
	144	6/24/2005	1		
7	84	6/21/2005	V		

INTERFERENCE SEARCHED				
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